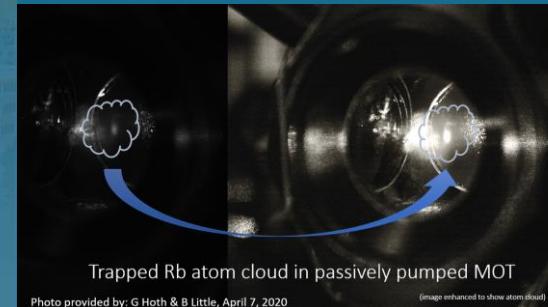




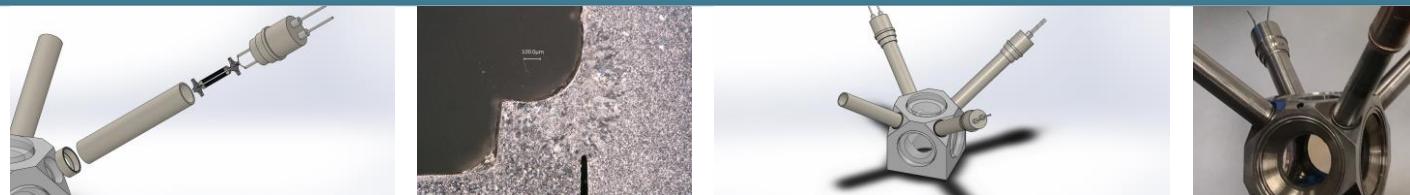
Sandia  
National  
Laboratories

# Fabricating a passively pumped vacuum chamber for cold-atom experiments



Trapped Rb atom cloud in passively pumped MOT

Photo provided by: G Hoth & B Little, April 7, 2020



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## 2021 International Brazing and Soldering Conference

October 3-6, 2021

Denver, Colorado



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## Vision/Motivation

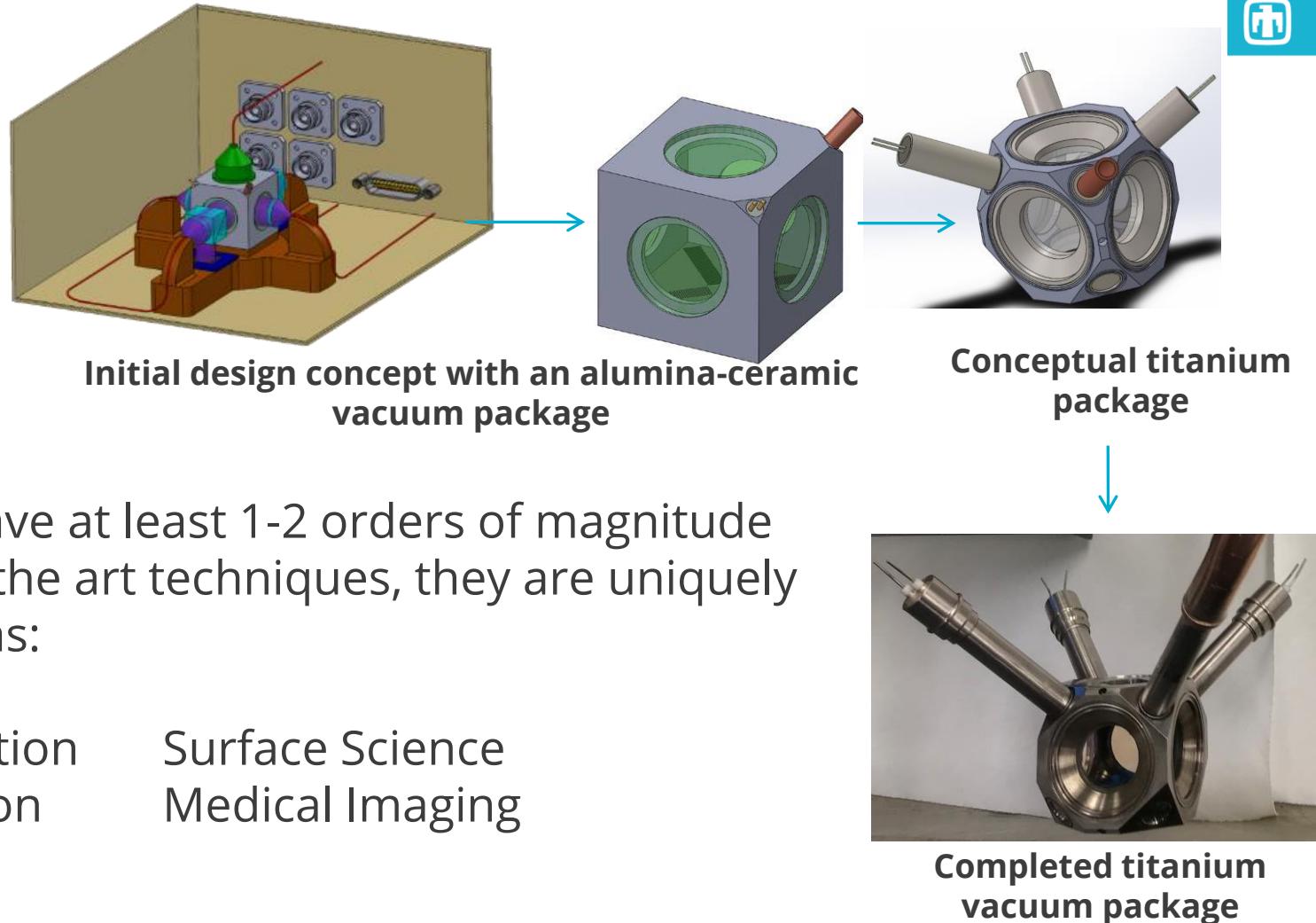
“Build the world’s first truly portable, compact atom interferometer inertial sensor.”

Because quantum sensors generally have at least 1-2 orders of magnitude better resolution than current state of the art techniques, they are uniquely suited to be used in such applications as:

Timing  
Navigation  
Gravimetry

Non Destructive Evaluation  
Trace Chemical Detection

Surface Science  
Medical Imaging



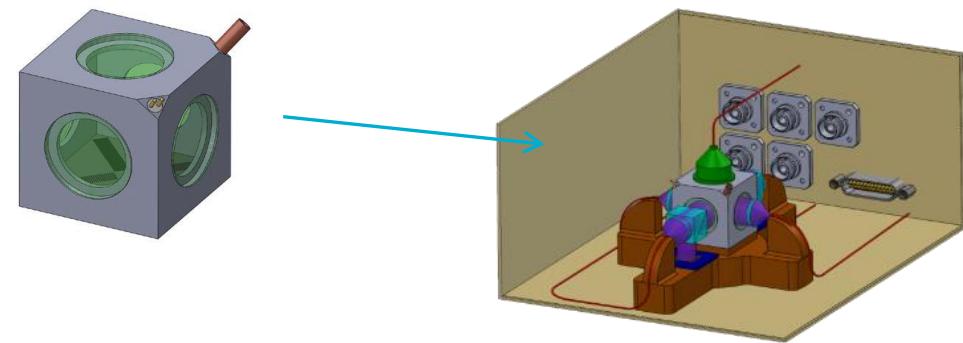
This presentation, approximately 15 minutes in duration, will summarize a 3-year multi-person effort, describing how small vacuum chambers, capable of supporting a magneto optical trap (MOT), via laser-cooling\*, were successfully fabricated.

\*Temperature:  $\sim 5\mu\text{K}$  ( $5 \times 10^{-6}$  Kelvin)

# Background: High-vacuum Chamber Features

## Required features

- Supply alkali metal (Rb) atoms
- Non or nearly nonmagnetic chamber and feedthroughs
- Small footprint,  $\sim 5 \text{ cm}^3$  volume to function as an atom interferometer (AI) accelerometer
- Must provide optical windows for laser access
- Must have negligible helium permeation
- **\*Maintain high-vacuum for months**
  - $P_{\text{Rb}} \sim 10^{-7} \text{ Torr}$ ;  $P_{\text{background}} \sim 10^{-8} \text{ Torr}$



## Desired Features

- **\*Electrically activated contaminant-free alkali metal source.**
- 100% glass-free
- Windows with nearly zero helium permeability, AR coating, and no birefringence
- Include passive (getter) pumping
- Support up to 6 months “pumpless” vacuum package operation.
- MOT diffraction grating internal to vacuum package
- Copper pinch-off tube for sealing
- Bakeable to  $\sim 400^\circ \text{C}$ .
- Zero/low electrical conductivity (<<< eddy currents)

## \*Key Vacuum System Challenges

# Materials & Components Selection



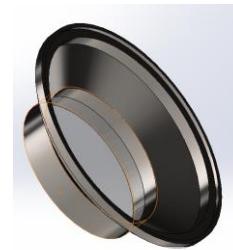
Component	Material	Heat sensitive	Atmosphere sensitive	Notes
<b>Chamber</b>	Titanium*	No	No	Grade-2 (commercially pure). Can be welded without the formation of intermetallics
<b>Chamber</b>	Alumina Ceramic	No	No	94% - 98% $\text{Al}_2\text{O}_3$
<b>Non-evaporable getters (NEG)</b>	NEG, St 172*	Yes	Yes	Sensitive above 250°C in $\text{O}_2$ containing environments
<b>Alkali Metal Dispenser (AMD)</b>	AMD, Rb*	Yes	Yes	Sensitive above 250°C in $\text{O}_2$ containing environments
<b>Window</b>	<b>Sapphire w/Ti frame*</b>	No	No	Brazed into frames. Able to withstand 450°C+ temperatures
<b>Window</b>	Sapphire w/o frame	Yes	No	CTE mismatch with Ti body could be problematic
<b>Window</b>	Fused Silica w/Ti frame	No	No	Brazed into frames. Able to withstand 450°C+ temperatures
<b>Window</b>	Fused Silica w/o frame	Yes	No	CTE mismatch with Ti body could be problematic
<b>Grating MOT</b>	Si wafer*	Yes	No	Need to keep below 250°C
<b>Electrical feedthroughs</b>	<b>Ti bodies, Mo* conductors</b>	No	No	Grade-2 Ti, brazed to $\text{Al}_2\text{O}_3$ insulators and Mo pins
<b>Electrical feedthroughs</b>	Stainless-steel bodies	No	No	Used initially until Ti bodies became available. Pins are Mo.
<b>NEG &amp; AMD bodies</b>	<b>Ti tubing*</b>	No	No	Grade-2 Ti
<b>Exhaust tubing</b>	<b>Ti and/or Ti/Cu*</b>	No	No	Brazed to adapters as needed.

\*Candidate materials selected for first iteration of vacuum chamber assemblies

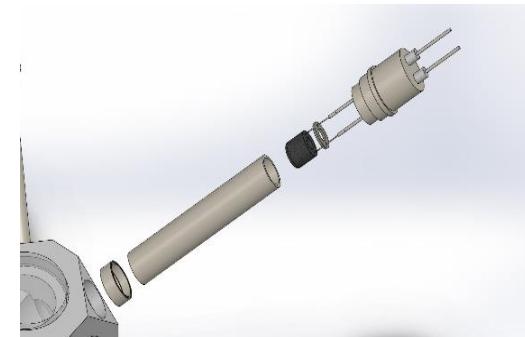
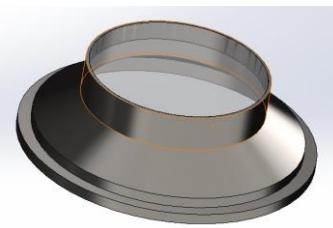
# Chamber Components Construction



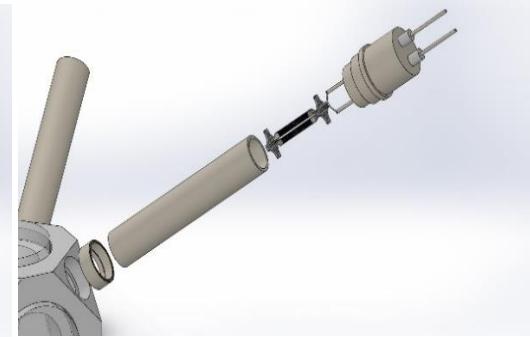
**Window Assemblies  
Getter Assemblies  
Alkali Metal  
Dispensers  
Exhaust Manifolds**



Sapphire window/CP titanium flanges



Non-evaporable getter assembly (L), Alkali metal dispenser assembly (R)



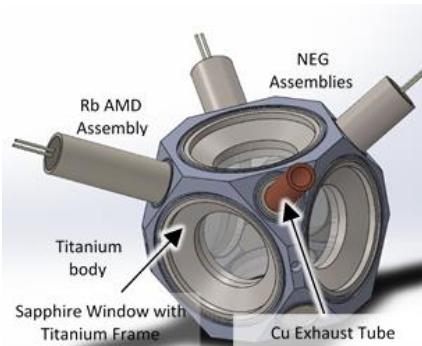
## Joining Processes

### Welding Processes

- Pulsed-laser
- Resistance
- Orbital
- TIG

### Brazing Processes

- Vacuum Furnace
- Hydrogen/Oxygen Torch
- Hand-held Induction

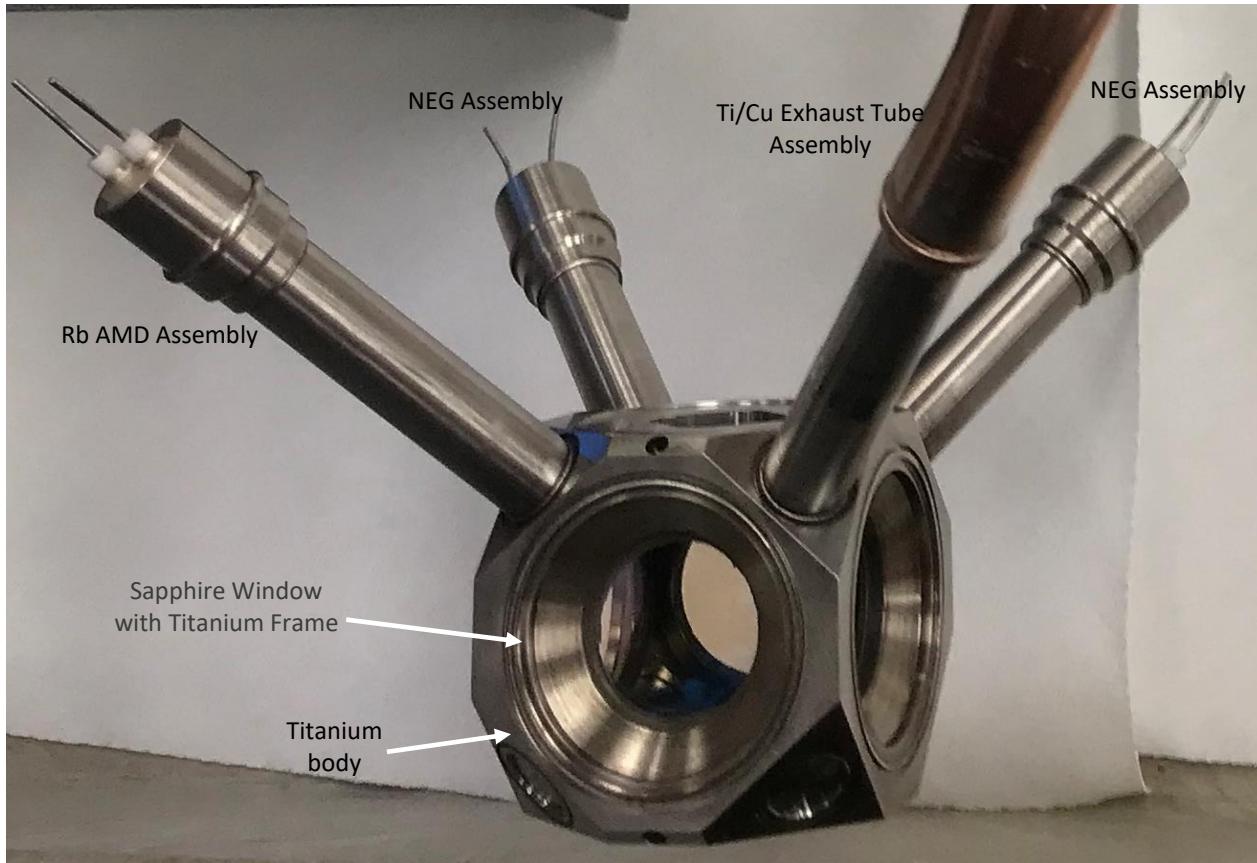


Sapphire window/CP titanium flanges



Pulsed-laser welding of CP titanium

# Titanium Vacuum Chamber Fabrication



Completed Titanium Vacuum Package



Solid-model of Titanium chamber/UHV manifold assembly

# Sapphire-Alumina Ceramic Braze Development



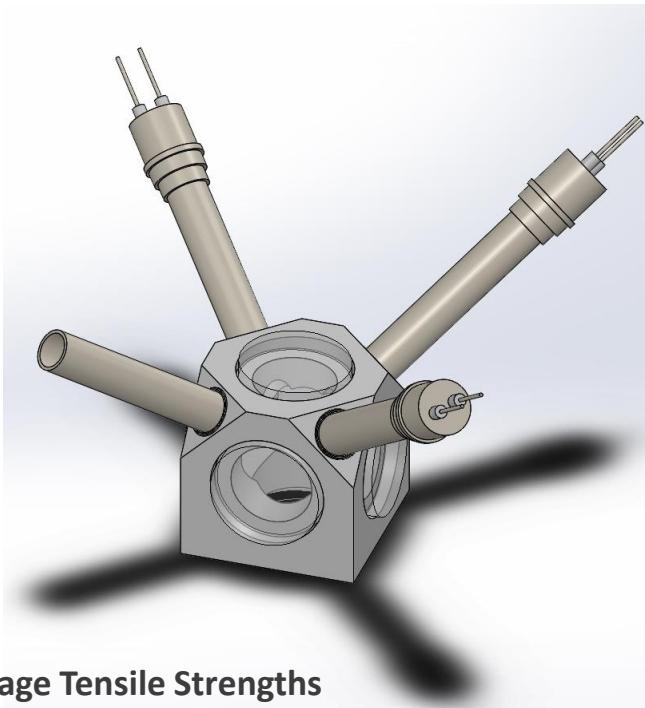
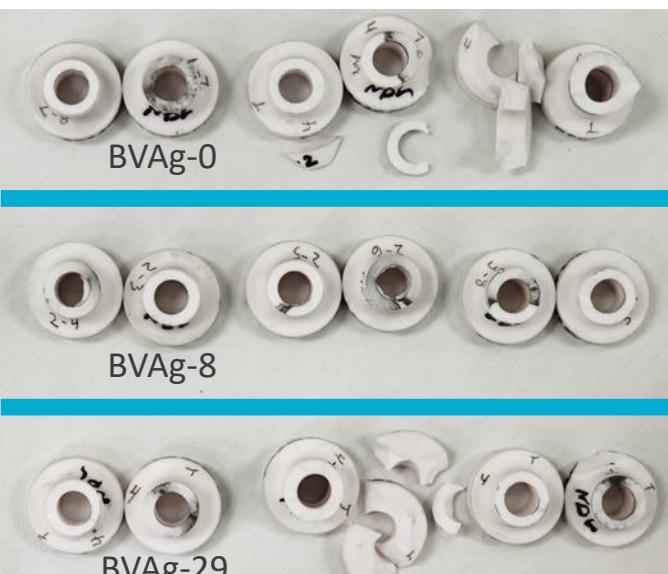
## Alumina-ceramic chamber design restrictions:

- Ten simultaneous active filler metal brazements (6 ea. sapphire window, 4 titanium weld sleeves) was determined to be too risky, as any leaks detected would be difficult to repair.
- The requirement that any metallization system used be nonmagnetic eliminated those utilizing nickel plating.

## Solution:

A COTS titanium-hydride/organic carrier metallization system (Tiger Ink) was selected for use after robust testing using with conventional silver-based brazing filler metals (BVAg-0, BVAg-8, and BVAg-29).

All of the ceramic tensile button samples and sapphire window-ceramic window frame samples fabricated using the Tiger-Ink metallization were hermetic (Helium leak rate <5E-12 atm/cc-sec).

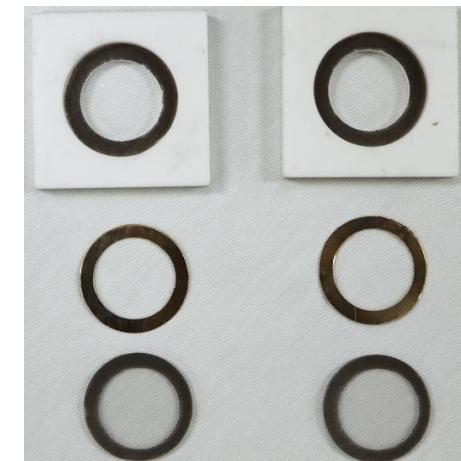


## Average Tensile Strengths

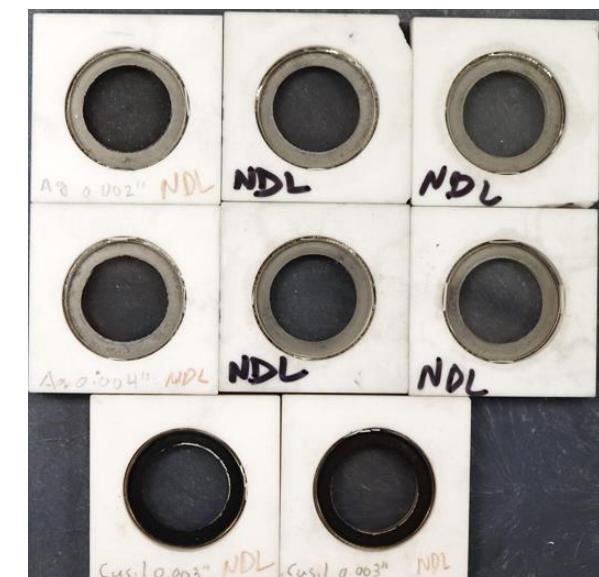
96% Alumina Ceramic ASTM F-19  
Tensile Buttons w/TiH<sub>2</sub> metallization.  
No metal interlayers.

Braze Filler Metal AWS Classification	Stress at failure KSI / MPa
BVAg-0	21.4 / 147.5
BVAg-8	23.7 / 163.4
BVAg-29	22.8 / 157.2

Tensile testing (ASTM F-19)  
Instron 5969, Rate:  $3 \times 10^{-4}$  inch/sec

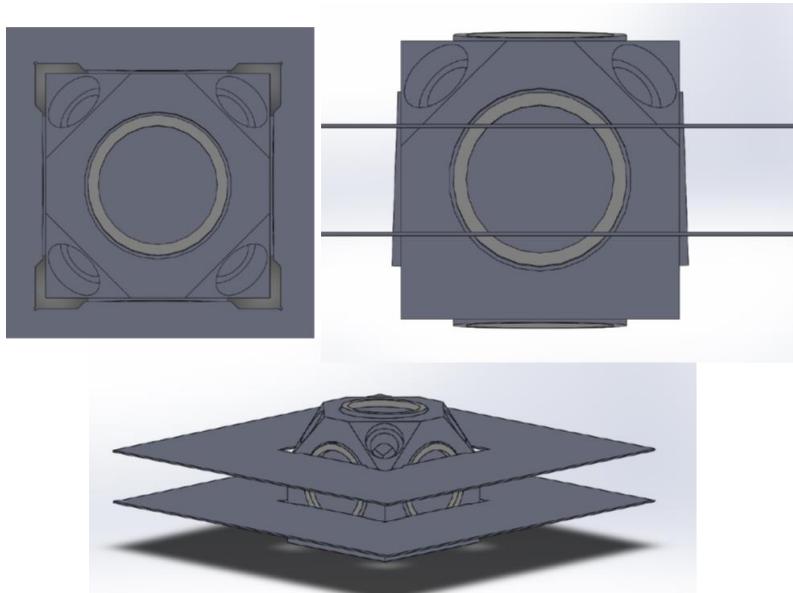


Metallized ceramic and sapphire windows with BFM preforms

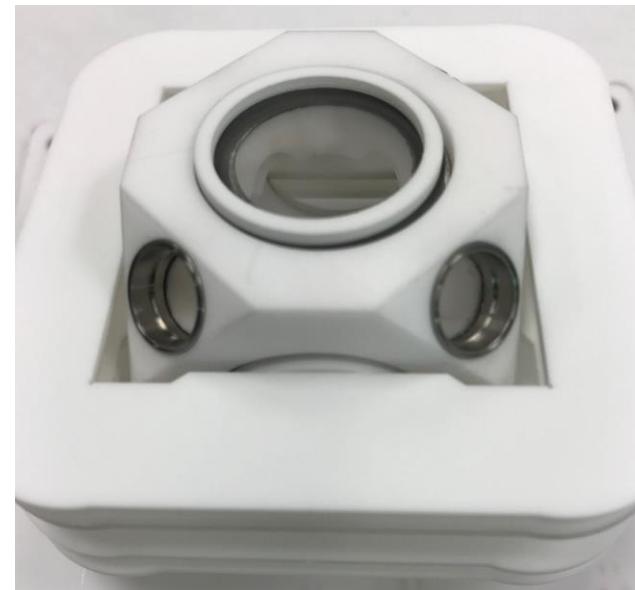


Brazed Alumina ceramic-sapphire window samples.

# Alumina-Ceramic Vacuum Chamber Assembly



Solid Model of Ceramic Chamber with  
Laser-Machined Alumina Ceramic  
Fixturing



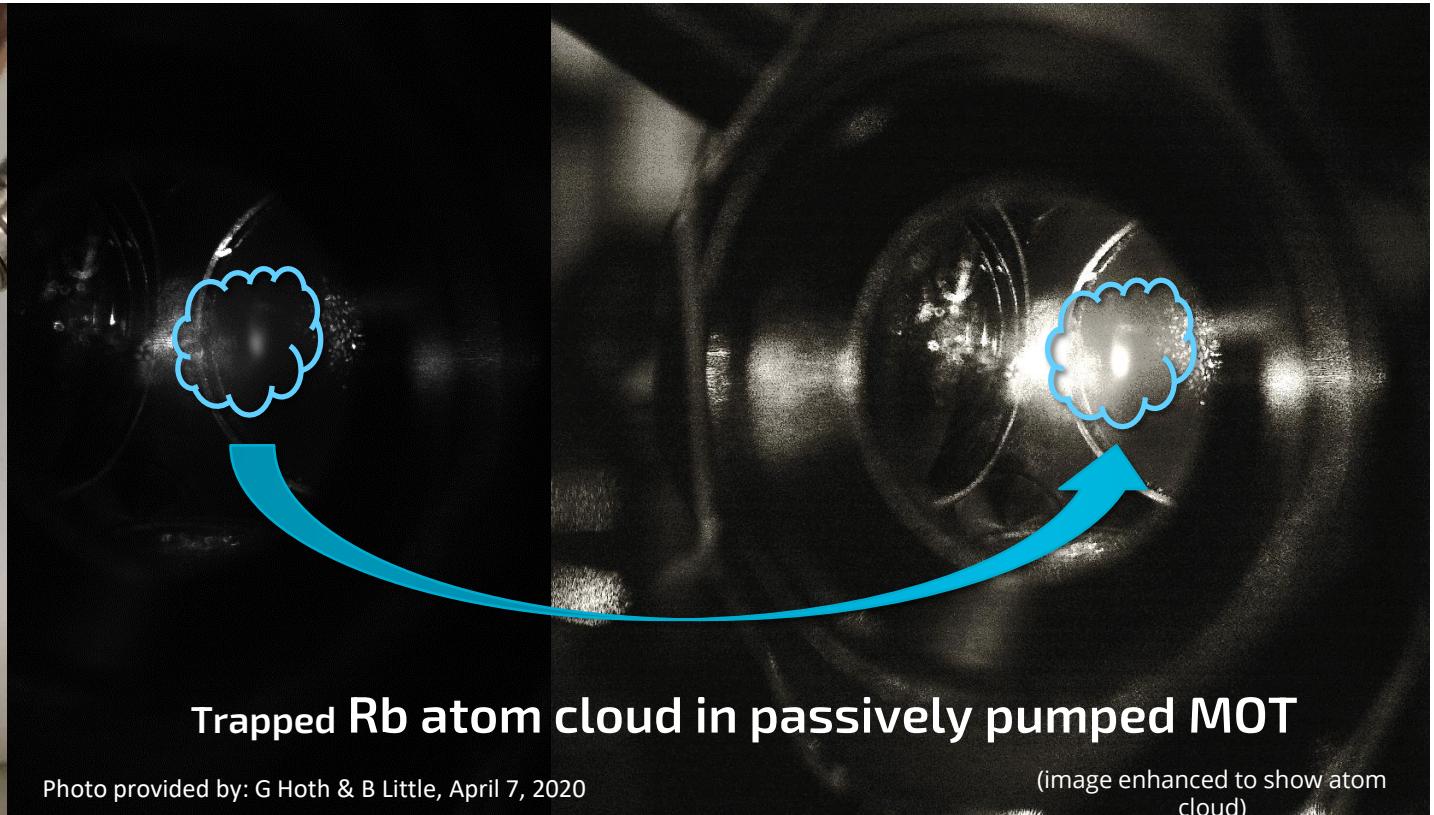
Alumina Ceramic Chamber with Laser-  
Machined Alumina Ceramic Fixturing Prior  
to Brazing



Brazed Ceramic  
Chamber

# Conclusion

- Multiple small titanium vacuum chambers, capable of supporting a magneto optical trap (MOT), via laser-cooling were successfully fabricated and tested.
- Alumina ceramic chambers were partially constructed, but not completed.
- Chambers removed from external vacuum sources have been supporting a MOT for over 450 days.



# Thank you for your time & attention!



## Acknowledgements

A special thank you to the following people whose technical assistance and expertise made this program a success: Justin Christensen, Peter Duran, Jack Herrmann, Greg Hoth, Toby Johnson, Peter Kinney, Jongmin Lee, Bethany Little, Christina Profazi, Mark Reece, Jeff Rodelas, Peter Schwindt, James Scott, Dan Tung, and Matt Vieira

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